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Amendment Under 37 C.F.R. § 1.116
Group Art Unit 1763, Expedited Procedure

Okay TO Enter
W/ RCE

03500.015313

PATENT APPLICATION

1/21/05

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
HIROSHI IZAWA ET AL.)
Application No.: 09/837,459)
Filed: April 19, 2001)
For: DEPOSITED-FILM)
FORMATION APPARATUS,)
DEPOSITED-FILM)
FORMATION PROCESS,)
VACUUM SYSTEM, LEAK)
JUDGMENT METHOD, AND)
COMPUTER-READABLE)
RECORDING MEDIUM WITH)
RECORDED LEAK-JUDGMENT-)
EXECUTABLE PROGRAM : December 1, 2004

VDE

Commissioner for Patents
MAIL STOP AF
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

A. Introductory Comments

In response to the final Office Action dated September 2, 2004, please
amend the above-identified application as follows.

12/03/2004 CNGUYEN 00000045 09837459

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88.00 OP